

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/500,425		OFGS File No. P/2107-253		
		Applicant Achim WEBER				
		Filing Date September 7, 2004		Group Art Unit 1645		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate
	US-					
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FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation Yes No
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
/MY/		Y. Xia et al., "Soft Lithography", <i>Angew. Chem. Int. Ed.</i> , 37:550-575 (1998).				
Examiner	/Melanie Yu/ (11/06/2007)		Date Considered			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						